## Chen-Hsuan Lu

## List of Publications by Year in descending order

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1937685 1872680 6 39 4 6 citations h-index g-index papers 6 6 6 58 docs citations times ranked citing authors all docs

#	Article	IF	CITATIONS
1	Negative capacitance from the inductance of ferroelectric switching. Communications Physics, 2019, 2, .	5.3	14
2	Single-Step Direct Growth of Graphene on Cu Ink toward Flexible Hybrid Electronic Applications by Plasma-Enhanced Chemical Vapor Deposition. ACS Applied Materials & Enhanced Chemical Vapor Deposition.	8.0	10
3	Polymer-Compatible Low-Temperature Plasma-Enhanced Chemical Vapor Deposition of Graphene on Electroplated Cu for Flexible Hybrid Electronics. ACS Applied Materials & Samp; Interfaces, 2021, 13, 41323-41329.	8.0	6
4	Graphene on Nanoscale-Thick Au Films: Implications for Anticorrosion in Smart Wearable Electronics. ACS Applied Nano Materials, 2022, 5, 4343-4349.	5.0	5
5	Low-Temperature Conformal Atomic Layer Etching of Si with a Damage-Free Surface for Next-Generation Atomic-Scale Electronics. ACS Applied Nano Materials, 2019, 2, 4578-4583.	5.0	3
6	Pâ€60: Singleâ€Step Plasmaâ€Enhanced Chemical Vapor Deposition of Graphene on Cu Ink and Sputtered Cu Thin Films. Digest of Technical Papers SID International Symposium, 2020, 51, 1565-1568.	0.3	1